

## Application Data Sheet

### Application Information

Application number::

Filing Date::

Application Type::

Regular

Subject Matter::

Utility

Title ::

BEAM HOMOGENIZER AND  
LASER IRRADIATION  
APPARATUS AND METHOD  
OF MANUFACTURING  
SEMICONDUCTOR DEVICE

Attorney Docket Number::

0756-7197

Total Drawing Sheets::

10

Small Entity?::

No

### Applicant Information

Applicant Authority Type::

Inventor

Primary Citizenship Country::

Japan

Given Name::

Koichiro

Middle Name::

Family Name::

TANAKA

Name Suffix::

City of Residence::

Atsugi

State or Province of Residence::

Kanagawa

Country of Residence::

Japan

Street of mailing address:: c/o Semiconductor Energy  
Laboratory Co., Ltd., 398,  
Hase  
City of mailing address:: Atsugi-shi  
State or Province of mailing address:: Kanagawa-ken  
Country of mailing address:: Japan  
Postal or Zip Code of mailing address:: 243-0036

### Correspondence Information

Correspondence Customer Number :: 31780  
E-Mail address:: erobinson@riplo.com

### Representative Information

Representative Customer Number:: 31780

### Domestic Priority Information

Application ::	Continuity Type::	Parent Application::	Parent Filing Date::

## Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2002-272812	09/19/2002	Yes

## Assignee Information

Assignee name::	Semiconductor Energy Laboratory Co., Ltd.
Street of mailing address::	398 Hase
City of mailing address::	Atsugi-shi
State or Province of mailing address::	Kangawa-ken
Country of mailing address::	Japan
Postal or Zip Code of mailing address::	243-0036